

Electronic Acknowledgement Receipt

EFS ID:	1145651
Application Number:	10689617
Confirmation Number:	4799
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device
First Named Inventor:	Satoru Okamoto
Customer Number:	26171
Filer:	John F. Hayden/Christine Tomlinson
Filer Authorized By:	John F. Hayden
Attorney Docket Number:	12732-170001
Receipt Date:	08-AUG-2006
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Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	yes
Payment was successfully received in RAM	\$450
RAM confirmation Number	18
Deposit Account	061050
The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows: Charge any Additional Fees required under 37 C.F.R. Section 1.16 and 1.17	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages				
1		Amendment.pdf	1133868	yes	28				
	Multipart Description								
	Doc Desc		Start	End					
	Amendment - After Non-Final Rejection		1	1					
	Claims		2	24					
	Applicant Arguments/Remarks Made in an Amendment		25	28					
Warnings:									
Information:									
2	Fee Worksheet (PTO-875)	fee-info.pdf	8188	no	2				
Warnings:									
Information:									
Total Files Size (in bytes):			1142056						
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>									